

RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2834

00684.003049

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:) : Examiner: B. Mullins	
SHIGETO KAMATA, ET AL.) : Group Art Unit: 2834	TECH
Application No.: 09/619,665)	草与沿
Filed: July 19, 2000	·)	CEIV
For: LINEAR MOTOR STAGE SYSTEM FOR USE IN EXPOSURE APPARATUS) :) July 3, 2002	VED 2002 ENTER 2800

Box AF Commissioner for Patents Washington, D.C. 20231

AMENDMENT AFTER FINAL REJECTION

Sir:

In response to the Office Action of April 3, 2002, please amend the above-identified application as follows: